



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4563

SERIAL NUMBER 10/529,535	FILING OR 371(c) DATE 03/29/2005 RULE	CLASS 427	GROUP ART UNIT 1762	ATTORNEY DOCKET NO. JO 01915
-----------------------------	--	--------------	------------------------	------------------------------------

## APPLICANTS

Pyung-Yong Um, Kyungki-do, KOREA, REPUBLIC OF;

## \*\* CONTINUING DATA \*\*\*\*

This application is a 371 of PCT/KR03/01915 09/19/2003

## \*\* FOREIGN APPLICATIONS \*\*\*\*

REPUBLIC OF KOREA 10-2002-0059372 09/30/2002

## \*\* SMALL ENTITY \*\*

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 6	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials			

## ADDRESS

27667

## TITLE

Method for depositing nitride film using chemical vapor deposition apparatus of single chamber type

FILING FEE RECEIVED 450	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-------------------------------	---	--